Tabletop-scale EUV coherent imaging using High Harmonic Light

Henry C. Kapteyn KMLabs Inc. and JILA













Talk overview

- Tabletop coherent EUV light sources high-order harmonic generation.
- Revolution in coherent imaging: 14 nm spatial resolution @13.5nm.
- Progress in commercial "tabletop x-ray laser" light sources– the KMLabs XUUS₄[™].



High Harmonic Generation: atomic response to extremely bright light

• Take a few-cycle (~10⁻¹⁴ sec) laser pulse, focus to ~10¹⁴ W cm⁻²:





McPherson, 1987 Ferray, 1988



High Harmonic Generation



Röntgen X-ray Tube







Coherent light from UV to keV: High Harmonic Generation





High pressure waveguide





30nm HHG beam (2002)





13nm HHG beam (2004)





3nm HHG beam (2010)



1nm HHG beam (2012)

Science **280**, 1412 (1998) Science **297**, 376 (2002) Science **336**, 1287 (2012) Science **348**, 530 (2015) Science **350**, 1225 (2015)



Revolution in coherent X-ray sources and imaging

Facility scale

- Synchrotron and free electron lasers
- EUV to 12 keV (EUV to hard X-rays)
- Nano to femto time resolution
- High flux
- Tunable
- Facility scale beamline w/support



Tabletop

- High harmonic sources
- mid-IR to 1 keV (EUV to soft X-rays)
- Sub-femtosecond time resolution
- Lower flux at higher $h\nu$
- Hyperspectral
- Tabletop for easy student/industry access



Tabletop X-rays "see" new materials/nano science



Revolution in X-ray Imaging: 3D coherent imaging of opaque materials with elemental, chemical, magnetic mapping

REVIEW

Beyond crystallography: Diffractive imaging using coherent x-ray light sources

Jianwei Miao,¹* Tetsuya Ishikawa,² Ian K. Robinson,^{3,4} Margaret M. Murnane⁵





- Diffraction-limited imaging $\approx \lambda/2NA$
- Image thick samples in 3D
- Inherent contrast for X-rays
- Phase and amplitude image contrast
 - Transmission or reflection
- Robust to vibrations
- Most photon-efficient form of imaging!

Advanced in coherent diffractive imaging (CDI)

Initial approaches to CDI (until 2011) A

- Required isolated sample or beam
- Transmission mode only



Fienup, Opt. Lett.. **3**, 27 (1978) Miao *et al.*, Nature, **400**, 342 (1999)

Advanced CDI (2016)

- Ptychographic CDI with overlapping beams
- Robust reflection and transmission modes
- Absolute interface structure determination
- 3D structure w/o tilting or sectioning
- Hyperspectral, multibeam, direct retrieval



Rodenburg *et al.*, PRL **98**, 034801 (2007) Thibault *et al.*, Science **321**, 379 (2008) Maiden *et al.*, Ultramicroscopy **109**, 1256 (2009)

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General tabletop reflection-mode full field microscope



- Full field image of extended objects
- Arbitrary angle of incidence with tilted-plane correction
- Algorithm can correct for imperfect scanning stages
- Can use multiple colors and beams for elemental, chemical, spin contrast
- Reflection and transmission
- Limits in spatial/temporal resolution, speed, not known

Ultramicroscopy **109**, 1256 (2009) Optica **1**, 39 (2014) Science **348**, 530 (2015) Laser Focus World (2015) Ultramicroscopy **158**, 98 (2015)

High contrast tabletop reflection-mode CDI (λ ~ 30 nm)

- Better contrast images than JILA SEM
 - phase contrast, element-specific reflectance
- 3D imaging: spatial resolution 1.3λ horizontal (<40nm), <5Å profile height
- <1 minute HHG exposure time for full image (old laser, bad optics)
- Less damage than AFM or SEM
- Unlimited working distance
- Faster detector readout needed
 - <1 min exposure; >90 min readout
- New cluster image reconstruction, detectors, and lasers being implemented as KMLabs / JILA collaboration

Science **348**, 530 (2015) Laser Focus World (May 2015) Ultramicroscopy **158**, 98 (2015) Opt. Exp. **19**, 22470 (2011)







ultramicroscopy

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SEM



Quantitative CDI: height/composition/tomography maps



Determining the spatial resolution – 3 approaches



Ultramicroscopy 158, 98 (2015)



Seeing through buried layers and interfaces



- CDI amplitude image enables imaging of elemental composition through 100nm of AI
- Quantitative non-destructive imaging of elemental and interfacial properties due to changes in EUV reflectivity
- Identified interdiffusion of AI into Cu, and formation of thin AI oxide layer on SiO₂



Postdeadline paper, Frontiers in Optics (2015), doi: 10.1364/FIO.2015.FW6B.2

Reflectivity of **uncoated** damascene shows oxide layer



Reflectivity of **coated** damascene shows interdiffusion – should be able to measure doping profiles



High contrast tabletop transmission-mode CDI @ 13.5 nm

- Using λ = 13.5 nm, spatial resolution of 14 nm
 - Spatial resolution **1.04** λ (PMMA zone plate sample)
 - Record spatial resolution for this wavelength
 - Requires ultrastable engineered HHG XUUS source
- Not yet resolution or speed limited
 - Exposure time ~ 10 sec/ μ m²
 - Orders of magnitude increase in speed possible



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 - Requires ultrastable engineered HHG XUUS source
- Next Steps
 - Use single-stage, >20W average power cryocooled
 - Optimize HHG scheme (optimized XUUS)
 - Improve resolution to sub-10nm— simply by moving
 - Reflective geometry







- NA: Supports 14.4 nm Resolution
- Lineout: Supports 14.4 nm Resolution
- PSD: Supports 14.2 nm Resolution: improve resolution to sub-10nm





Power Spectral Density

0.5 2 10 50 Spatial Frequency (μm⁻¹)

Gardner et al., in prep

270%

Record 13.5nm imaging using ANY light source

TABLETOP HHG COHERENT IMAGING



2011 HHG Results

- Toy sample
- Simple CDI algorithm
- resolution

New Record 13.5nm Imaging Results (2016)

- Full field, high contrast ptychography
- New record 14 nm resolution (1.04 λ)
- Can increase spatial resolution; extend to reflection mode



FACILITY-SCALE ZONE PLATE IMAGING



Chao et al. Optics Express 17, 17669 (2009)

Synchrotron Source

- Zone plate image, 12nm resolution
- Used 2nm illumination



XUUS₄[™] critical for new 13nm CDI



- Optimized for high average-power, high rep-rate, drive lasers: 1 to >200kHz
- Complete HHG XUUS source and beamline
- Active input laser beam stabilization 4 axis control
- Ultrastable HHG beam intensity, wavefront, beam
- Temperature stabilized breadboard
- Stable, industrial optical mounting
- Complete software control

Medium-term stability data – preliminary

- Integrated HHG light source
 - Optimized for high average-power, high rep-rate, drive lasers: 1 to >100kHz
 - Cartridge waveguide: increased stability, performance, optimized at 13.5nm
 - Active input beam stabilization 4 axis control
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EUV Beam- preliminary

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XUUS4 EUV Beam







New driver lasers for HHG: record >20W Ti:sapphire and fiber lasers

- KMLabs has developed a record 25W single stage Ti:sapphire system for science market
- Repetition rates from kHz to MHz
- M² ~1.1– flawless Gaussian beam
- Unprecedented power and stability
- New XUUS_{4.2} will enable >10x increase in HHG flux in 10 – 20 nm region
- Compact >25W hybrid fiber lasers also under development
- ≈10⁻⁴ 10⁻⁷ into 1 harmonic order









Record Pulse Duration Performance for fiber laser

- Pulse duration over >100 hours of temperature cycling
- 90 ± 2.2 fs, <0.4% amplitude stability over 14°-28° C temp cycling
- Necessary "front end" system for future compact diode-pumped ultrafast systems





- Coherent diffractive imaging is rapidly establishing itself as the "gold standard" for EUV imaging
 - Large, redundant data set allows one to obtain a *full characterization* of how an object scatters incident light
 - i.e. everything you could *ever* know using light at that wavelength
 - With **NO** instrumental distortions/limitations
- Near future (JILA→ KMLabs) versatile general purpose 13 nm microscope
- Broader applications of HHG EUV microscopy to support nanoscience Have been demonstrated and remain to be fully-developed
 - Interfaces
 - Mechanical properties (Young's Modulus, Poisson ratio)
 - Magnetic properties
 - Dynamic behavior

HHG output powers

- 10⁻⁴ to 10⁻⁶ into one harmonic order at 30nm depending on HHG scheme
- Using mid-IR lasers, supercontinua ideal for spectroscopy (NEXAFS, MOKE)
- Using UV lasers, isolated HHG peaks ideal for imaging and metrology
- Using 2W, 1kHz, 0.8µm laser, achieve 10¹⁰ photons/s/1% band @ 13nm
- Using 2W, 1kHz, 0.8µm laser, achieve 160nW, 1% band @ 13nm
- Using 2W, 1kHz, 0.27µm laser, achieve >µW in λ/Δλ≈400 @ 13nm (still in research)
- Using 15W, 1kHz, laser, achieve >15µW in 1 order @ 30nm



STROBE: UCLA FORT LEWIS COLLEGE Colorado NSF STC on Functional Imaging w/ Electrons and Light Berkeley FIU NISTAU Knowledge Transfer **Electron imaging**

Routine 3D atomic Capturing and monitoring resolution structure individual atoms in 3D **Education research**, of biological complexes N \mathbf{M} broadening participation **Functional 3D Imaging various** imaging of energy, Non-Crystalline forms of energy magnetic and flow and fileds Structure spintronic materials across interfaces X-ray **Multi-D Electron Microscopy** Ultrafast Correlative Imaging Microscopy Detector Algorithm Nano, correlative, h **Big Data** Functional 3D Advanced Optical imaging Super Nano-Imaging X-ray Imaging Resolution

Underpinning technologies





Detectors, algorithms

